



**ELECTRONIC COPY**

LG771639444  
Report verification at igi.org



April 20, 2026  
IGI Report Number **LG771639444**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **11.83 X 5.09 X 2.84 MM**

**GRADING RESULTS**

Carat Weight **1.00 CARAT**  
Color Grade **H**  
Clarity Grade **VS 1**

April 20, 2026  
IGI Report Number **LG771639444**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **MARQUISE BRILLIANT**  
Measurements **11.83 X 5.09 X 2.84 MM**

**GRADING RESULTS**

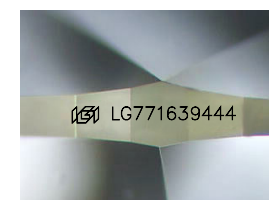
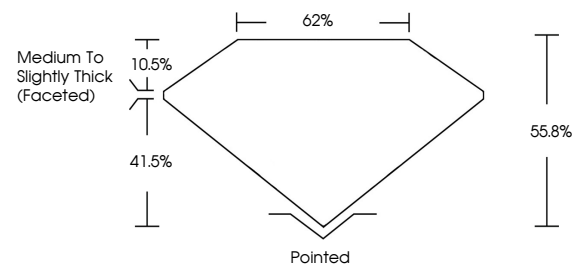
Carat Weight **1.00 CARAT**  
Color Grade **H**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG771639444**

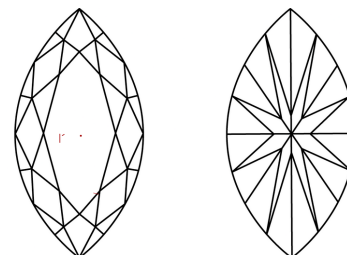
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

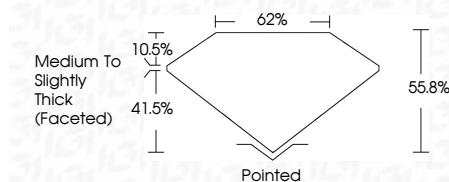
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG771639444**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



**IGI**



April 20, 2026  
IGI Report No LG771639444  
**MARQUISE BRILLIANT**  
11.83 X 5.09 X 2.84 MM  
1.00 CARAT H  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Medium to Slightly Thick (Faceted)  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
Pointed  
VERY GOOD  
EXCELLENT  
NONE  
IGI LG771639444

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa